

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the Application of

Akiohiro MURATA

Application No.: 09/245,288

Filed: February 5, 1999

For: SEMICONDUCTOR APPARATUS SUBSTRATE,
SEMICONDUCTOR APPARATUS, AND METHOD
OF MANUFACTURING THEREOF AND
ELECTRONIC APPARATUS

Group Art Unit: 2827

Examiner: David E. Graybill

Docket No.: 101937

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

☒ Applicant further requests entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 154465 in the amount of ☒ \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Yong S. Choi
Registration No. 43,324

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JAO:YSC/dmw

Date: May 28, 2004

Attachments:

Petition for Extension of Time
Amendment

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461